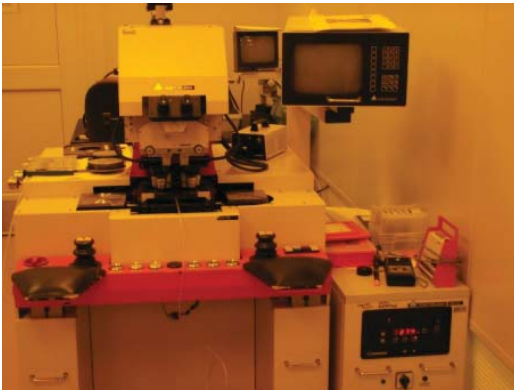




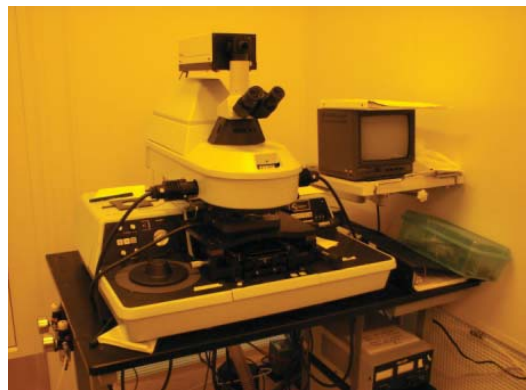
CONTACT LITHOGRAPHY MASK MAKING SUITE

Contact Lithography: Proven, reliable methods for micro-scale patterning



Karl Suss MA-56

- 2,3,4" wafers and pieces
- 350W Lamp



Quintel Aligner

- 2,3" wafers and pieces
- IR backside alignment

Mask Making Suite: In-house mask making allows for more creativity and design flexibility at reduced cost



GCA 3600 Pattern Generator

- 6" x 6" Write Field
- 2 μ m minimum aperture
- ~5K flash/hr



GCA 3696 PhotoRepeater

- 6" x 6" Flash Field
- 1 μ m minimum
- 10x reduction
- 10 x 10mm maximum die